

Electronic Patent Application Fee Transmittal

Application Number:	10628174			
Filing Date:	28-Jul-2003			
Title of Invention:	PROCEDURE FOR ETCHING OF MATERIALS AT THE SURFACE WITH FOCUSED ELECTRON BEAM INDUCED CHEMICAL REACTION AT SAID SURFACE			
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Attorney Docket Number:	8183			
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Utility under 35 USC 111(a) Filing Fees				
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Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Printed copy of patent - no color	8001	5	3	15
Total in USD (\$)				1825